

The effectiveness of pressure safety valves in chemical supply systems to prevent fire, explosion, and overpressure in the Korean semiconductor industry

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Fire (Basel, Switzerland)

2023; 6(9):e344

ARTICLE IDENTIFIERS

DOI: 10.3390/fire6090344

PMID: unavailable

PMCID: not available

JOURNAL IDENTIFIERS

LCCN: not available

pISSN: not available

eISSN: 2571-6255

OCLC ID: 1048108112

CONS ID: not available

US National Library of Medicine ID: 101749049

This article was identified from a query of the SafetyLit database.